

## INVENTOR INFORMATION

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## CORRESPONDENCE INFORMATION

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## APPLICATION INFORMATION

Title Line One:: BEAM HOMOGENIZER, LASER IRRADIATION APPA  
Title Line Two:: RATUS, SEMICONDUCTOR DEVICE, AND METHOD  
Title Line Three:: OF FABRICATING THE SEMICONDUCTOR DEVICE  
Total Drawing Sheets:: 29  
Formal Drawings?:: Yes  
Application Type:: Utility  
Docket Number:: 740756-2256  
Secrecy Order in Parent Appl.?:: No

## REPRESENTATIVE INFORMATION

Representative Customer Number:: 22204  
Registration Number One:: 38285  
Registration Number Two:: 35483  
Registration Number Three:: 41345  
Registration Number Four:: 45285  
Registration Number Five:: 26477

## PRIOR FOREIGN APPLICATIONS

Foreign Application One:: 2000-024615  
Filing Date:: 02-01-2000  
Country:: Japan  
Priority Claimed:: Yes

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